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| 10/689,617 | 10/22/2003 RULE | 438 | 1792 | 12732-170001 |

APPLICANTS
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**** CONTINUING DATA *******

**** FOREIGN APPLICATIONS *******
 JAPAN 2002-310257 10/24/2002

**** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****
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|---|---|--|----------------------------------|-----------------------------|---------------------------|---------------------------------|
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | <input type="checkbox"/> Met after Allowance | STATE OR COUNTRY JAPAN | SHEETS DRAWINGS 9 | TOTAL CLAIMS 95 | INDEPENDENT CLAIMS 13 |
| Verified and /MAHMOUD DAHIMENE/ Acknowledged Examiner's Signature | Initials | | | | | |

ADDRESS
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TITLE
 Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device

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|------------------------------------|---|--|
| FILING FEE RECEIVED 2980 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees |
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